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NO. 2043 P. 6

JUL 12 2007

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: METALORGANIC CHEMICAL VAPOR DEPOSITION (MOCVD)
PROCESS AND APPARATUS TO PRODUCE MULTI-LAYER HIGH-
TEMPERATURE SUPERCONDUCTING (HTS) COATED TAPE

App. No.: 10/602,468

Filed: June 23, 2003

Examiner: Aaron Austin

Group Art Unit: 1775

Customer No.: 34456

Confirmation No.: 2661

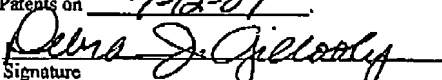
Atty. Dkt. No.: 1014-SP156-US

MS AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Final Office Action mailed February 12, 2006, please amend the
above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>7-12-07</u> .	
Debra J. Gillooly	
Typed or Printed Name	Signature